

IN THE U.S. PATENT AND TRADEMARK OFFICE

I N F O R M A T I O N S H E E T

Applicant: FUJIMURA, Shigeto
 ASAHI, Toshiaki
 SATO, Kenji

Application No.:

Filed: January 4, 2001

For: PROCESS FOR PRODUCING COMPOUND SEMICONDUCTOR SINGLE CRYSTAL

Priority Claimed Under 35 U.S.C. 119 and/or 120:

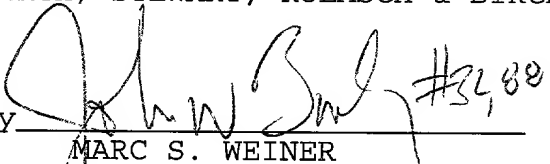
COUNTRY	DATE	NUMBER
JAPAN	01/07/00	2000-1675

Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP
 P. O. Box 747
 Falls Church, Virginia 22040-0747
 (703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By  #32,181

MARC S. WEINER

Reg. No. 32,181

P. O. Box 747

Falls Church, VA 22040-0747

/rr

(703) 205-8000